

Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/711,676	CHUNG ET AL.
Examiner	Art Unit	
Tan Ho	2821	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
343	822	8/19/05	T.H.
↓	895	↓	↓
333	26	↓	↓
U.S.-PG-PVB		↓	↓